

Tao Hang

List of Publications by Year in descending order

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105
papers

2,752
citations

201385

27
h-index

205818

48
g-index

105
all docs

105
docs citations

105
times ranked

3439
citing authors

#	ARTICLE	IF	CITATIONS
1	Battery-free, skin-interfaced microfluidic/electronic systems for simultaneous electrochemical, colorimetric, and volumetric analysis of sweat. <i>Science Advances</i> , 2019, 5, eaav3294.	4.7	497
2	Super-hydrophobic nickel films with micro-nano hierarchical structure prepared by electrodeposition. <i>Applied Surface Science</i> , 2010, 256, 2400-2404.	3.1	163
3	Preparation of super-hydrophobic Cu/Ni coating with micro-nano hierarchical structure. <i>Materials Letters</i> , 2012, 67, 327-330.	1.3	103
4	Sweat-activated biocompatible batteries for epidermal electronic and microfluidic systems. <i>Nature Electronics</i> , 2020, 3, 554-562.	13.1	99
5	Characterization of nickel nanocones routed by electrodeposition without any template. <i>Nanotechnology</i> , 2008, 19, 035201.	1.3	93
6	Electrochemical impedance spectroscopy analysis for lithium-ion battery using Li ₄ Ti ₅ O ₁₂ anode. <i>Journal of Power Sources</i> , 2013, 222, 442-447.	4.0	92
7	Hollow nitrogen-doped carbon spheres as efficient and durable electrocatalysts for oxygen reduction. <i>Chemical Communications</i> , 2014, 50, 9473-9476.	2.2	88
8	Effect of Mg doping on the hydrogen-sensing characteristics of ZnO thin films. <i>Sensors and Actuators B: Chemical</i> , 2011, 160, 266-270.	4.0	78
9	Lotus leaf-like dual-scale silver film applied as a superhydrophobic and self-cleaning substrate. <i>Chemical Communications</i> , 2014, 50, 8405-8407.	2.2	54
10	Preparation and characterization of nickel-cobalt alloy nanostructures array fabricated by electrodeposition. <i>CrystEngComm</i> , 2014, 16, 6937.	1.3	52
11	A facile process for preparing superhydrophobic nickel films with stearic acid. <i>Surface and Coatings Technology</i> , 2013, 231, 88-92.	2.2	50
12	Effects of process parameters on bondability in ultrasonic ball bonding. <i>Scripta Materialia</i> , 2006, 54, 293-297.	2.6	47
13	High-adhesive superhydrophobic 3D nanostructured silver films applied as sensitive, long-lived, reproducible and recyclable SERS substrates. <i>Nanoscale</i> , 2014, 6, 9720.	2.8	45
14	Growth Mechanism and Field Emission Properties of Nickel Nanocones Array Fabricated by One-Step Electrodeposition. <i>Journal of the Electrochemical Society</i> , 2010, 157, D624.	1.3	44
15	Transient Light-Emitting Diodes Constructed from Semiconductors and Transparent Conductors that Biodegrade Under Physiological Conditions. <i>Advanced Materials</i> , 2019, 31, e1902739.	11.1	43
16	Electrodeposition and characterization of copper nanocone structures. <i>CrystEngComm</i> , 2015, 17, 868-876.	1.3	41
17	Silicon composite thick film electrodeposited on a nickel micro-nanocones hierarchical structured current collector for lithium batteries. <i>Journal of Power Sources</i> , 2013, 222, 503-509.	4.0	39
18	High-performance Si-based 3D Cu nanostructured electrode assembly for rechargeable lithium batteries. <i>Journal of Materials Chemistry A</i> , 2015, 3, 11912-11919.	5.2	36

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19	Structural control of a cobalt nanocone array grown by directional electrodeposition. <i>CrystEngComm</i> , 2010, 12, 2799.	1.3	35
20	Electrodeposited nanostructured cobalt film and its dual modulation of both superhydrophobic property and adhesiveness. <i>Applied Surface Science</i> , 2015, 324, 319-323.	3.1	35
21	Long lasting behavior of Gd ₂ O ₃ :Eu ³⁺ phosphor synthesized by hydrothermal routine. <i>Materials Chemistry and Physics</i> , 2008, 107, 142-147.	2.0	34
22	Electrochemical impedance analysis of electrodeposited SiO ₂ /C composite thick film on Cu microcones-arrayed current collector for lithium ion battery anode. <i>Journal of Power Sources</i> , 2014, 256, 226-232.	4.0	34
23	Controlled crystallization of glass-ceramics with two nucleating agents. <i>Materials Characterization</i> , 2009, 60, 1529-1533.	1.9	31
24	Effect of a trace of Cr on intermetallic compound layer for tin-zinc lead-free solder joint during aging. <i>Journal of Alloys and Compounds</i> , 2009, 470, 429-433.	2.8	31
25	Morphologies and wetting properties of copper film with 3D porous micro-nano hierarchical structure prepared by electrochemical deposition. <i>Applied Surface Science</i> , 2016, 372, 7-12.	3.1	31
26	Growth behavior of tin whisker on SnAg microbump under compressive stress. <i>Scripta Materialia</i> , 2018, 147, 114-118.	2.6	30
27	Behaviors of Chloride Ions in Methanesulfonic Acid Bath for Copper Electrodeposition of Through-Silicon-Via. <i>Journal of the Electrochemical Society</i> , 2013, 160, D146-D149.	1.3	29
28	Behavior of intermetallics formation and evolution in Ag ₈ Au ₃ Pd alloy wire bonds. <i>Journal of Alloys and Compounds</i> , 2014, 588, 622-627.	2.8	28
29	Performances of CaSiO ₃ ceramic sintered by Spark plasma sintering. <i>Materials Characterization</i> , 2008, 59, 256-260.	1.9	26
30	Influence of PEG molecular weight on morphology, structure and wettability of electroless deposited Cu-Ni-P films. <i>Applied Surface Science</i> , 2012, 258, 8814-8818.	3.1	26
31	Bioinspired Multifunctional Au Nanostructures with Switchable Adhesion. <i>Langmuir</i> , 2015, 31, 10850-10858.	1.6	26
32	Design of thermally stable insulation film by radical grafting poly(methylacrylic acid) on silicon surface. <i>Applied Surface Science</i> , 2019, 464, 627-635.	3.1	26
33	Electrodeposition of High Density Silver Nanosheets with Controllable Morphologies Served as Effective and Reproducible SERS Substrates. <i>Langmuir</i> , 2016, 32, 3385-3392.	1.6	24
34	Construction of liquid metal-based soft microfluidic sensors via soft lithography. <i>Journal of Nanobiotechnology</i> , 2022, 20, .	4.2	24
35	Low-Temperature Solid State Bonding of Sn and Nickel Micro Cones for Micro Interconnection. <i>ECS Solid State Letters</i> , 2012, 1, P7-P10.	1.4	23
36	Linear Sweep Voltammetric Study on the Copper Electrodeposition of Through-Silicon-Vias. <i>Journal of the Electrochemical Society</i> , 2014, 161, D349-D352.	1.3	23

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37	Study on the Adhesion Between Epoxy Molding Compound and Nanocone-Arrayed Pd Preplated Leadframes. <i>Journal of Electronic Materials</i> , 2007, 36, 1594-1598.	1.0	21
38	Three-Dimensional Hierarchical Nanostructured Cu/Ni-Co Coating Electrode for Hydrogen Evolution Reaction in Alkaline Media. <i>Nano-Micro Letters</i> , 2015, 7, 347-352.	14.4	21
39	Effects of 2-mercaptopyridine and Janus Green B as levelers on electrical resistance of electrodeposited copper thin film for interconnects. <i>Thin Solid Films</i> , 2019, 677, 39-44.	0.8	20
40	Highly durable non-sticky silver film with a microball-nanosheet hierarchical structure prepared by chemical deposition. <i>Chemical Communications</i> , 2013, 49, 10391-10393.	2.2	19
41	Applicable Superamphiphobic Ni/Cu Surface with High Liquid Repellency Enabled by the Electrochemical-Deposited Dual-Scale Structure. <i>ACS Applied Materials & Interfaces</i> , 2019, 11, 11106-11111.	4.0	19
42	Structure and wettability control of Cu-Ni-P alloy synthesized by electroless deposition. <i>Journal of Alloys and Compounds</i> , 2012, 538, 144-152.	2.8	17
43	Electrochemical deposition of Fe ₃ O ₄ nanoparticles and flower-like hierarchical porous nanoflakes on 3D Cu-cone arrays for rechargeable lithium battery anodes. <i>Materials and Design</i> , 2017, 121, 321-334.	3.3	17
44	Anti-wetting Cu/Cr coating with micro-posts array structure fabricated by electrochemical approaches. <i>Applied Surface Science</i> , 2013, 271, 369-372.	3.1	16
45	Tunable resistance switching in solution processed chromium-doped strontium titanate nanoparticles films. <i>Journal of Colloid and Interface Science</i> , 2017, 494, 178-184.	5.0	16
46	Electrodeposited three-dimensional porous SiO ₂ /C/Ni thick film as high performance anode for lithium-ion batteries. <i>Journal of Power Sources</i> , 2014, 272, 794-799.	4.0	15
47	Solid state diffusion between Sn and Cu microcones on Cu microcones. <i>Journal of Alloys and Compounds</i> , 2014, 582, 408-413.	2.8	15
48	Diffusion barrier performance of W/Ta-W-N double layers for Cu metallization. <i>Microelectronic Engineering</i> , 2006, 83, 423-427.	1.1	14
49	Microstructure evolution of Ag ₈ Au ₃ Pd alloy wire during electromigration. <i>Materials Characterization</i> , 2015, 110, 44-51.	1.9	14
50	One-Step Dipping Method for Covalently Grafting Polymer Films onto a Si Surface from Aqueous Media. <i>Langmuir</i> , 2016, 32, 8709-8716.	1.6	14
51	Grafting of PMMA brushes layer on Cu surface to create a stable superhydrophobic surface. <i>Applied Surface Science</i> , 2016, 386, 309-318.	3.1	14
52	Effects of Ni-W(Au) coated Cu microcones on the bonding interfaces. <i>Applied Surface Science</i> , 2015, 353, 774-780.	3.1	13
53	Electroless Silver Coating on Copper Microcones for Low-Temperature Solid-State Bonding. <i>Journal of Electronic Materials</i> , 2015, 44, 4516-4524.	1.0	13
54	Fabrication of superamphiphobic Cu surfaces using hierarchical surface morphology and fluorocarbon attachment facilitated by plasma activation. <i>Applied Surface Science</i> , 2019, 464, 140-145.	3.1	12

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55	Structural effect of inhibitors on adsorption and desorption behaviors during copper electroplating for through-silicon vias. <i>Electrochimica Acta</i> , 2021, 372, 137907.	2.6	12
56	Formation of SnAg solder bump by multilayer electroplating. <i>Microelectronic Engineering</i> , 2013, 106, 33-37.	1.1	11
57	Effect of electroplating layer structure on shear property and microstructure of multilayer electroplated Sn ^{3.5} Ag solder bumps. <i>Microelectronics Reliability</i> , 2013, 53, 321-326.	0.9	11
58	Competitive Effect of Leveler's Electrochemical Behavior and Impurity on Electrical Resistance of Electroplated Copper. <i>Journal of the Electrochemical Society</i> , 2019, 166, D577-D582.	1.3	11
59	Effect of W addition on the electroless deposited NiP(W) barrier layer. <i>Applied Surface Science</i> , 2013, 282, 632-637.	3.1	10
60	Study of free air ball formation in Ag ⁸ Au ³ Pd alloy wire bonding. <i>Microelectronics Reliability</i> , 2014, 54, 2550-2554.	0.9	10
61	Wetting process of copper filling in through silicon vias. <i>Applied Surface Science</i> , 2015, 359, 736-741.	3.1	10
62	Transient and Biocompatible Resistive Switching Memory Based on Electrochemically Deposited Zinc Oxide. <i>Advanced Electronic Materials</i> , 2021, 7, 2100322.	2.6	10
63	Ultralow Set Voltage and Enhanced Switching Reliability for Resistive Random-Access Memory Enabled by an Electrodeposited Nanocone Array. <i>ACS Applied Materials & Interfaces</i> , 2022, 14, 25710-25721.	4.0	10
64	Covalent Grafting of Tethered Homopolymer Film on p-Si(100). <i>Langmuir</i> , 2016, 32, 3746-3753.	1.6	9
65	A View on Annealing Behavior of Cu-Filled Through-Silicon Vias (TSV). <i>ECS Journal of Solid State Science and Technology</i> , 2016, 5, P389-P392.	0.9	9
66	Three-dimensional porous nickel supported Sn ^O C composite thin film as anode material for lithium-ion batteries. <i>RSC Advances</i> , 2015, 5, 31275-31281.	1.7	8
67	Effects of Sn grain size on intermetallic compounds formation in 5 μm diameter Cu/Sn pillar bumps. <i>Journal of Materials Science: Materials in Electronics</i> , 2018, 29, 19484-19490.	1.1	8
68	Facile synthesis of petal-like nanocrystalline Co ₃ O ₄ film using direct high-temperature oxidation. <i>Journal of Materials Science</i> , 2019, 54, 7922-7930.	1.7	8
69	The influence of non-uniform copper oxide layer on tin whisker growth and tin whisker growth behavior in SnAg microbumps with small diameter. <i>Materials Letters</i> , 2020, 258, 126773.	1.3	8
70	Covalently formation of insulation and barrier layers in high aspect ratio TSVs. <i>Applied Surface Science</i> , 2022, 573, 151588.	3.1	8
71	Study on the behaviors of Cu filling in special through-silicon-vias by the simulation of electric field distribution. <i>Microelectronic Engineering</i> , 2014, 116, 1-5.	1.1	7
72	Low-Temperature Insertion Bonding using Electroless Cu-Co-P Micro-Cones Array with Controllable Morphology. <i>Electronic Materials Letters</i> , 2021, 17, 459-470.	1.0	7

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73	Communicationâ€”Fabrication of Vertical Nanotwinned Copper with (220) Texture by Direct Current Electrodeposition. Journal of the Electrochemical Society, 2021, 168, 082506.	1.3	7
74	Solâ€”Gel-Derived Biodegradable Er-Doped ZnO/Polyethylene Glycol Nanoparticles for Cell Imaging. ACS Applied Nano Materials, 2022, 5, 7103-7112.	2.4	7
75	Enhanced Ni ₃ Sn ₄ nucleation and suppression of metastable NiSn ₃ in the solid state interfacial reactions between Sn and cone-structured Ni. CrystEngComm, 2013, 15, 10490.	1.3	6
76	A low-temperature solid-state bonding method based on copper bump coated with nickel microcones and silver buffer. Materials Letters, 2016, 181, 165-168.	1.3	6
77	Diffusion barrier effect of Ta/Ti bilayer in organic dielectric/Cu interconnects. Thin Solid Films, 2018, 653, 113-118.	0.8	6
78	Influence of intercolony boundary on corrosion behavior of electrodeposited Niâ€”W alloy for electronic connector applications. Materials Chemistry and Physics, 2020, 239, 121989.	2.0	6
79	A carbon mixed amorphous-TiS _x separator coating for lithium sulfur batteries. Materials Chemistry and Physics, 2021, 258, 123923.	2.0	6
80	Effects of W contents on the solid-state interfacial reactions of Sn/Co-W. Journal of Materials Science, 2022, 57, 1403-1415.	1.7	6
81	Quasiâ€”Periodical 3D Hierarchical Silver Nanosheets with Subâ€”10 nm Nanogap Applied as an Effective and Applicable SERS Substrate. Advanced Materials Interfaces, 2015, 2, 1500359.	1.9	5
82	Rapid Determination of the Electrodeposition Potential for Cu Superfilling Using a Nanocones Array Structured Electrode. Journal of the Electrochemical Society, 2018, 165, D339-D343.	1.3	5
83	Study on the relationship between Cu protrusion behavior and stresses evolution in the through-silicon via characterized by in-situ ¹³ C-Raman spectroscopy. Microelectronics Reliability, 2020, 115, 113949.	0.9	5
84	The Evolution of Microstructure and Resistance in Electroplated Copper Films by Linear Integrated Laser Scanning Annealing. Electronic Materials Letters, 2021, 17, 207-214.	1.0	5
85	Wetting process of electrolyte in high density Cu/Sn micro-bumps electrodepositing. Applied Surface Science, 2011, 257, 3723-3727.	3.1	4
86	IMC Growth at the Interface of Snâ€”2.0Agâ€”2.5Zn Solder Joints with Cu, Ni, and Niâ€”W Substrates. Journal of Electronic Materials, 2014, 43, 4119-4125.	1.0	4
87	Formation and growth of interfacial intermetallic layers of Snâ€”8Znâ€”3Biâ€”0.3Cr on Cu, Ni and Niâ€”W substrates. Microelectronics Reliability, 2014, 54, 245-251.	0.9	4
88	Grafting and properties of a porous poly(methyl methacrylate) film on a silicon surface by a oneâ€”step dipping method. Journal of Applied Polymer Science, 2017, 134, 44930.	1.3	4
89	Fluorineâ€”Free Nanoporous Lowâ€”k Dielectric Film Covalently Grafted on Si via Aryldiazonium Chemistry. Advanced Materials Interfaces, 0, , 2101127.	1.9	4
90	Electroless plating copper cones on leadframe to improve the adhesion with epoxy molding compound. , 2012, , .		3

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91	Chemical metallization of ultrathin polymer insulation film for through-silicon via application. Thin Solid Films, 2021, 734, 138842.	0.8	3
92	Two-Step Electrodeposited 3D Ni Nanocone Supported Au Nanoball Arrays as SERS Substrate. Journal of the Electrochemical Society, 2020, 167, 142502.	1.3	3
93	Application of electrodeposited Cu-metal nanoflake structures as 3D current collector in lithium-metal batteries. Nanotechnology, 2022, 33, 245406.	1.3	3
94	Electroless Grafting of Polymer Insulation Layers in Through-Silicon Vias. ECS Journal of Solid State Science and Technology, 2019, 8, P591-P595.	0.9	2
95	In situ synthesis of a highly cross-linked polymethacrylimide ultrathin film on a silicon wafer with applicable dielectric, thermal, and mechanical properties. Thin Solid Films, 2020, 711, 138308.	0.8	2
96	The performance and degradation process of a greenly synthesized transient heterojunction diode. Thin Solid Films, 2020, 712, 138312.	0.8	2
97	Impurity diffusion behavior study of electroplated copper films annealed by linear shaping laser mobile scanning system. Materials Letters, 2021, 292, 129446.	1.3	2
98	Low temperature bonding with metallic micro-cones for 3D integration. , 2012, , .		1
99	Study of gold wire bonding on 0.1 μm soft gold film substrate. , 2014, , .		1
100	The Influence of Leveler on the Impurity Behavior of Electroplated Cu Films During Laser Annealing. Journal of the Electrochemical Society, 2021, 168, 062504.	1.3	1
101	Development of robust amphiphobic hierarchical structure on polymer substrate by thermal imprinting and sputter etching. Surface and Coatings Technology, 2021, 427, 127804.	2.2	1
102	Liner Sweep Voltammetry Electroplating Method to Synthesize Large Monocrystalline Cu Cones for Interconnection. Electronic Materials Letters, 2022, 18, 27-35.	1.0	1
103	Fast Determination of the Potential for Cu Superfilling Using a Nanoporous Electrode. , 2019, , .		0
104	Grafting of a porous polymethyl methacrylate (PMMA) film on the silicon surface with low dielectric constant. , 2020, , .		0
105	Effect of leveler on electrical resistance and microstructural of electroplated copper after heat treatment. , 2021, , .		0